

Docket No. 245557US0S X  
IN RE APPLICATION OF: Masanobu OGINO, et al.  
SERIAL NO: 10/713,054  
FILED: November 17, 2003  
FOR: SEMICONDUCTOR SUBSTRATE AND METHOD OF MANUFACTURE THEREOF



RESPONSE UNDER 37 CFR 1.113-  
EXPEDITED PROCEDURE EXAMINING  
GROUP 283

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

Transmitted herewith is an Amendment and Request for Reconsideration in the above-identified application.

- ☒ No additional fee is required  
☐ Small entity status of this application under 37 C.F.R. §1.9 and §1.27 is claimed.  
☐ Additional documents filed herewith:

The Fee has been calculated as shown below:

CLAIMS	CLAIMS REMAINING		HIGHEST NUMBER PREVIOUSLY PAID	NO. EXTRA CLAIMS	RATE	CALCULATIONS
TOTAL	17	MINUS	20	0	x \$50 =	\$0.00
INDEPENDENT	6	MINUS	7	0	x \$200 =	\$0.00
APPLICATION SIZE		MINUS	100	0 (each addtl. 50 sheets)	x \$250 =	\$0.00
		<input type="checkbox"/> MULTIPLE DEPENDENT CLAIMS			+ \$360 =	\$0.00
		TOTAL OF ABOVE CALCULATIONS				\$0.00
		<input type="checkbox"/> Reduction by 50% for filing by Small Entity				\$0.00
		TOTAL				\$0.00

- ☐ A check in the amount of \$0.00 is attached.  
☐ Credit card payment form is attached to cover the fees in the amount of \$0.00  
☒ Please charge any additional Fees for the papers being filed herewith and for which no check or credit card payment is enclosed herewith, or credit any overpayment to deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.  
☒ If these papers are not considered timely filed by the Patent and Trademark Office, then a petition is hereby made under 37 C.F.R. §1.136, and any additional fees required under 37 C.F.R. §1.136 for any necessary extension of time may be charged to Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

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DOCKET NO: 245557US0S X



"RESPONSE UNDER 37 CFR 1.116-  
EXPEDITED PROCEDURE EXAMINING  
GROUP 2813"

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :  
MASANOBU OGINO, ET AL. : EXAMINER: NGUYEN, T. T.  
SERIAL NO: 10/713,054 :  
FILED: NOVEMBER 17, 2003 : GROUP ART UNIT: 2813  
FOR: SEMICONDUCTOR SUBSTRATE AND METHOD OF MANUFACTURE  
THEREOF

AMENDMENT AND REQUEST FOR RECONSIDERATION

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated April 25, 2006, reconsideration is requested in view of the following amendment and remarks:

**Amendments to the Claims** begin on page 2 of this response.

**Support for the Amendments** begin on page 7 of this response.

**Remarks** begin on page 8 of this response.